



香港中文大學

The Chinese University of Hong Kong

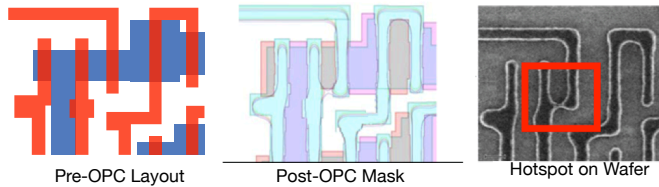
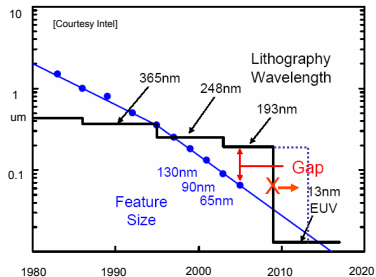
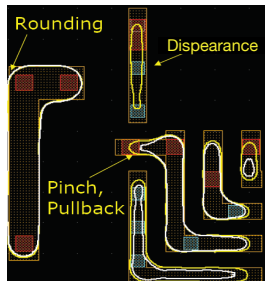
Machine Learning in Nanometer AMS Design-for-Reliability

Tinghuan Chen, Qi Sun and Bei Yu

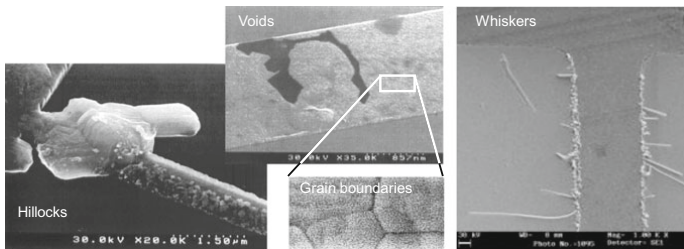
Department of Computer Science & Engineering

Chinese University of Hong Kong

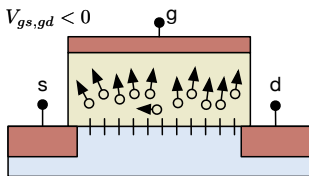
{thchen, qsun, byu}@cse.cuhk.edu.hk



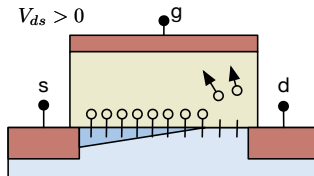
Lithography hotspots (GENG+, ICCAD'20)



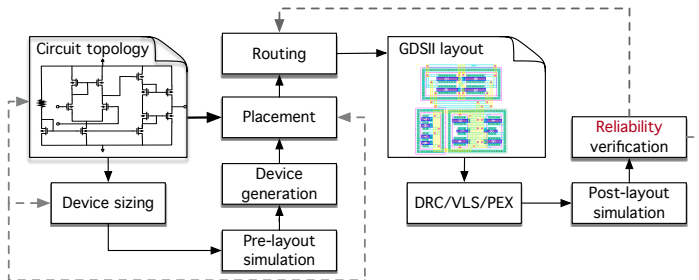
EM (Photo courtesy of G. H. Bernstein und R. Frankovic, University of Notre Dame)



BTI (CHEN+, ASPDAC'21)



HCI (CHEN+, ASPDAC'21)





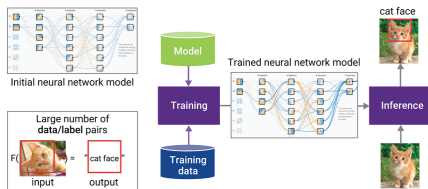
- Big Data

- Large unstructured data sets flood us everyday
- Facebook, LinkedIn, Amazon, Google



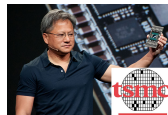
- Deep Neural Networks

- Approaching human intelligence



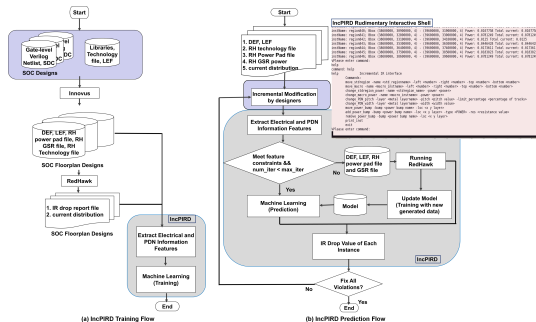
- Hardware advances

- GPU, FPGA, TPU, ...



ML-based Verification

Shallow model: IR-drop prediction



IncPIRD flow (HO+, ICCAD'19)

ML model

- Input features: chip/Block size, pitch of metal layer, pulldown and pullup component in node itself and its neighbors;
- Model: XGBoost;
- Output: IR drop value of each instance.



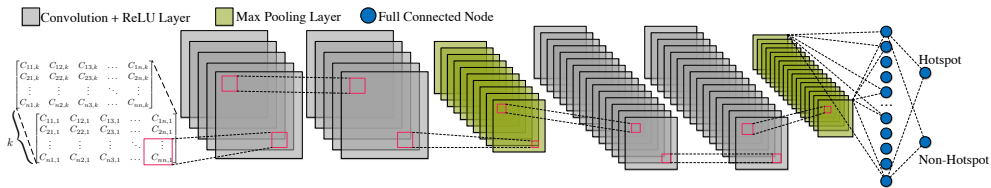
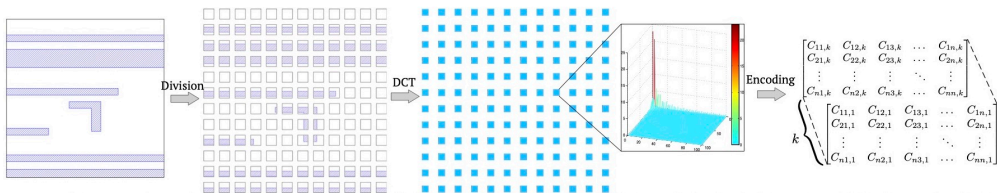
Drawbacks

- Needs complicated feature engines;
- Needs more domain knowledge;
- Features cannot be extracted by task orientation.

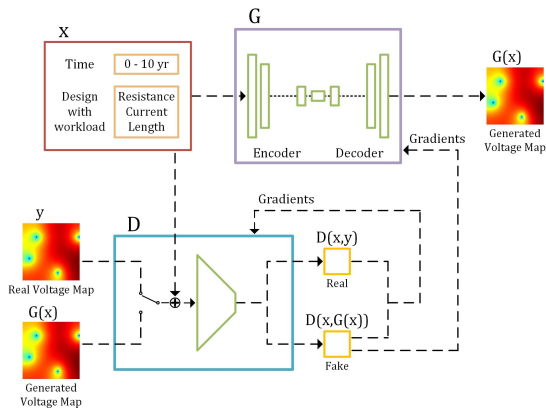
Solution

- Build a model with a certain “depth”;
- Use a learning algorithm to automatically learn a good feature representation.

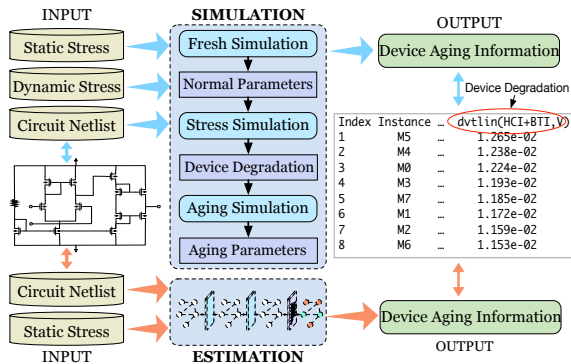
Convolutional neural networks: Lithography hotspot detection



CNN-based HSD flow (YANG+, DAC'17).

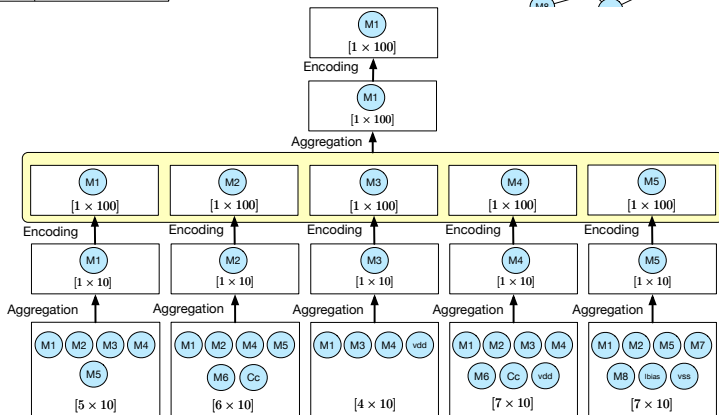
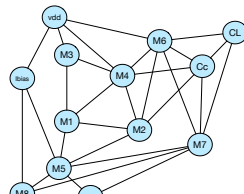
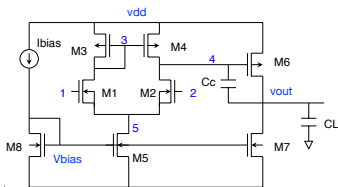


GAN-based EM-induced voltage prediction flow (ZHOU+, ICCAD'20).



GCN-based aging degradation flow (CHEN+, TCAD'21)

Node embedding

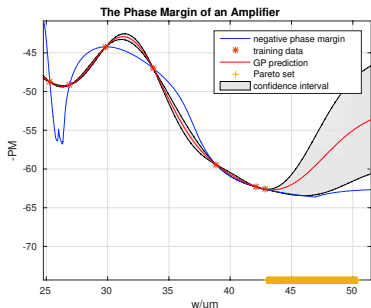


ML-based CAD Flow For DFR

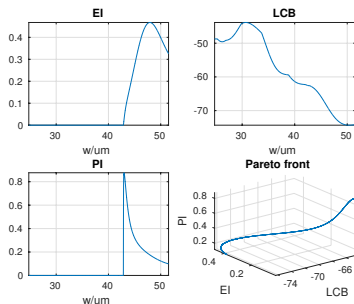


Objective

minimize $LCB(x)$, $-EI(x)$, $-PI(x)$

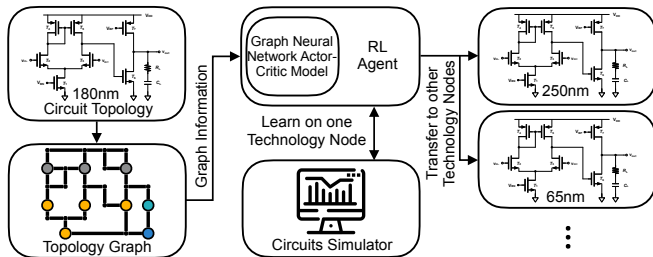


(a) True phase margin curve, GP predictions, and Pareto set

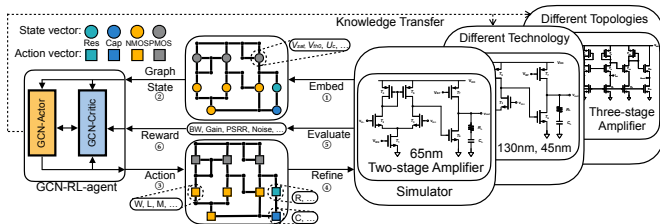


(b) The LCB, EI, and PI functions and the Pareto front

The multi-objective optimization (LYU+, ICML'18)



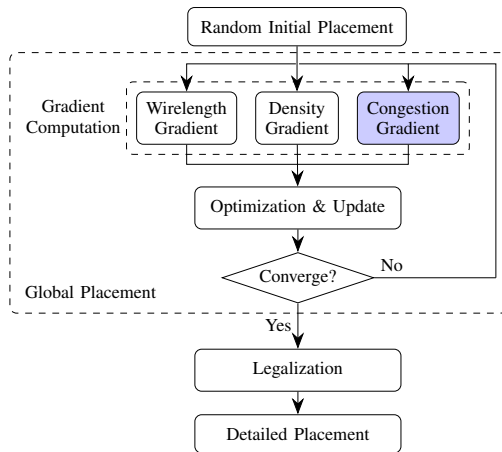
GNN-based Reinforcement Learning for Transistor Sizing





DREAMPlace Strategies (LIN+,DAC'19)

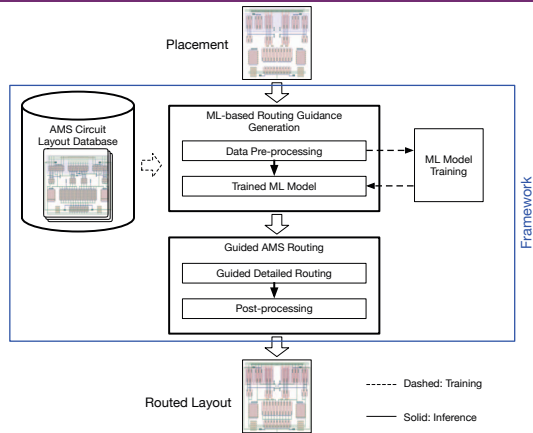
- Cast the non-linear placement problem into a neural network training problem.
- Leverage deep learning hardware (GPU) and software toolkit (e.g. PyTorch)
- Enable ultra-high parallelism and acceleration while getting the state-of-the-art results.



Routability Estimation \times DREAMPlace (LIU+,DATE'21)



Routing (Mimic the manual layout approach)



Overall flow (ZHU+, ICCAD'19)



**Open challenges and potential
directions**



Dilemma

- Inputting the entire design causes out-of-memory on GPU;
- Inputting a subcircuit netlist or layout tile cannot consider corresponding stress conditions.

Potential solutions

- Estimate the worst degradation;
- Incrementally, heuristically and hierarchically simulate subcircuits to obtain dynamic stress conditions.



Dilemma

- GP has limited fitting ability for the very complicated model;
- CNNs and GCNs cannot be directly integrated into the Bayesian optimization framework.

Potential solutions

- Neural processes and graph neural processes, which have the better fitting ability and provide estimation uncertainty.



Challenge

- It is difficult to model the performance and reliability, such as EMI noise, via routing layout and integrate ML-based models into routing cost function;
- in each search step, ML-based model inference has to be performed, which brings expensive computation.

Potential solutions

- The gradient values of the ML-based reliability model can be used as cost values in the routing stage;
- The gradient values are updated by the back-propagation for several routing nets to achieve a better trade-off between runtime and layout routing reliability quality.

Conclusion



Conclusion

- It is promising to apply ML techniques to achieve AMS circuits DFR with high efficiency.
- Some open challenges and promising solutions about ML are discussed in nanometer AMS circuits DFR.
- More studies promote the development of AMS circuits DFR.

THANK YOU!